

SVT Associates Molecular Beam Epitaxy (MBE) System

Used Semiconductor Deposition Equipment



FEATURES

- ✓ **Manufacturer:** SVT Associates
- ✓ **Equipment Type:**
Molecular Beam Epitaxy (MBE) System
- ✓ Includes control rack /
source control cabinet
- ✓ Includes UHV growth
chamber assembly
- ✓ Multiple source and process
control components
- ✓ Ideal for research and
thin film deposition applications
- ✓ Available for immediate inquiry



UHV GROWTH CHAMBER ASSEMBLY



MULTIPLE SOURCE & PROCESS COMPONENTS



FULL SYSTEM VIEW



PRECISION. PERFORMANCE. RESEARCH.

This SVT Associates MBE system combines a proven UHV growth chamber with a complete control and source management platform—engineered for advanced thin-film deposition, epitaxy and semiconductor materials research.



PLEASE NOTE:

This is a used system. Configuration shown is based on available photographed components. Specifications are provided to the best of our knowledge.